

~~PATENT~~

## **INFORMATION DISCLOSURE STATEMENT**

Applicant : Sherman  
Appl. No. : 10/683,727  
Filed : October 10, 2003  
For : SEQUENTIAL CHEMICAL  
VAPOR DEPOSITION  
Examiner : Eric B. Fuller  
Group Art Unit : 1762

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

December 22, 2006

(Date)

Andrew N. Merickel, Reg. No. 53,317

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing One (1) reference to be considered by the Examiner. Also enclosed is One (1) foreign patent reference and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing of a Notice of Allowance. This Statement is accompanied by the fees set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Respectfully submitted,

12/28/2006 FMETEK11 00000012 10683727

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KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: December 22, 2016

By:

Andrew N. Merickel  
Registration No. 53,317  
Attorney of Record  
Customer No. 20,995  
(415) 954-4114

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Please Direct All Correspondence to Customer Number **20995**

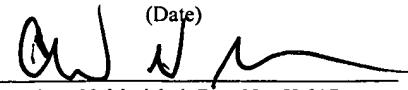
**TRANSMITTAL LETTER**  
**INFORMATION DISCLOSURE STATEMENT**

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 P.O. Box 1450  
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Dear Sir:

Enclosed for filing in the above-identified application are:

(X) An Information Disclosure Statement and PTO/SB/08 equivalent listing references for consideration:

(X) Listing 1 reference.  
 (X) Enclosing 1 reference.

(X) A check in the amount of \$180 to cover the fee for the Information Disclosure Statement is enclosed.

(X) Return prepaid postcard.

Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.



Andrew N. Merickel  
 Registration No. 53,317  
 Attorney of Record  
 Customer No. 20,995  
 (415) 954-4114

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>		Application No.	10/683,727
		Filing Date	October 10, 2003
		First Named Inventor	Sherman
		Art Unit	1762
<i>(Multiple sheets used when necessary)</i>		Examiner	Eric B. Fuller
SHEET 1 OF 1		Attorney Docket No.	ASMMC.9CP1DV1C1

DEC 27 2006

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear

FOREIGN PATENT DOCUMENTS					
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
					T <sup>1</sup>

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T <sup>1</sup>
		MÖLSÄ et al., "Deposition of Cerium Dioxide Thin Films on Silicon Substrates by Atomic Layer Epitaxy," Mat. Res. Soc. Symp., Vol. 325, 1994 Materials Research Society, pp. 341-350			

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Examiner Signature	Date Considered
<b>*Examiner:</b> Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

T<sup>1</sup> - Place a check mark in this area when an English language Translation is attached.